

Application No. 10/552,677

Docket No.: RPP 202-US (10510421)

Amendment under Rule 116	
I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted via the Office electronic filing system in accordance with § 1.8(a)(4).	
Dated: <u>2/28/11</u>	Signature: <u>Eileen Sheffield</u> (Eileen Sheffield)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Rudolf Beckmann

Application No.: 10/552,677

Confirmation No.: 2418

Filed: November 21, 2005

Art Unit: 1712

For: HIGH FREQUENCY PLASMA JET
SOURCE AND METHOD FOR
IRRADIATING A SURFACE

Examiner: N K. Ford

AMENDMENT UNDER RULE 116

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action dated December 3, 2010, and the telephone interview with the Examiner on December 13, 2010, please amend the above-identified U.S. patent application as follows: